IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

BOX PATENT APPLICATION
COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

24197

Transmitted herewith for filing is the patent application of:

Inventor(s): Teruaki Okino

For: CHARGED-PARTICLE-BEAM MICROLITHOGRAPHY METHODS AND
APPARATUS PROVIDING REDUCED RETICLE HEATING

Enclosed are:

⊠   24 pages of specification, 7 pages of claims, an abstract and a Combined
Declaration and Power of Attorney.

⊠   5 sheet(s) of drawings.

⊠   A certified copy of a Japanese Patent Application No. 2000-258588.

CLAIMS AS FILED

For	Claims Filed	Number Free		Number Extra	Rate	Basic Fee $710.00
Total Claims	22	20	=	2	$18.00	$ 36.00
Independent Claims	4	3	=	1	$80.00	$ 80.00
Multiple Dependent Claim Fee					$270.00	
TOTAL FILING FEE						$826.00

⊠   Applicant claims the benefit under 35 U.S.C. § 119 of the earlier filing date of foreign
application number 2000-258588, filed on August 29, 2000.

⊠   Assignee for this application is or will be Nikon Corporation, and applicant requests that
this information be listed on the published application.

⊠   A check in the amount of $826.00 to cover ⊠ filing fee and ☐ assignment recordal fee
is enclosed.

⊠   The Director is hereby authorized to charge any additional fees that may be required in
connection with the filing of this application and recording any assignment filed
herewith, or credit over-payment, to Account No. 02-4550. A copy of this sheet is
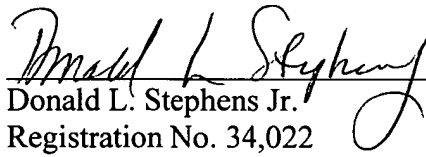enclosed.

☒   Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

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By _____
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cc: Docketing